

Dear Editor of the Review of Scientific Instruments

We thank you for sending our manuscript titled “Fast and high-yield fabrication of axially symmetric ion-trap needle electrodes via two step electrochemical etching” for review and accepting our petition of the previous decision.

We are disappointed to see that our rebuttal letter was not enough to change the Reviewer 1’s decision.

In our previous rebuttal letter, we had addressed the concerns raised by the reviewer and made changes to our manuscript based on all the actionable items. This can also be seen in the revised and the marked-up manuscript that was submitted. We have submitted a second rebuttal letter in response to the reviewer’s decision. However, we agree with you that an independent review is required at this point. As you had requested, we have suggested more than five appropriate potential reviewers who can be invited to review the manuscript. We hope that they can get back soon with their comments.

Sincerely,  
Nikhil Kotibhaskar  
PhD Student  
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University of Waterloo